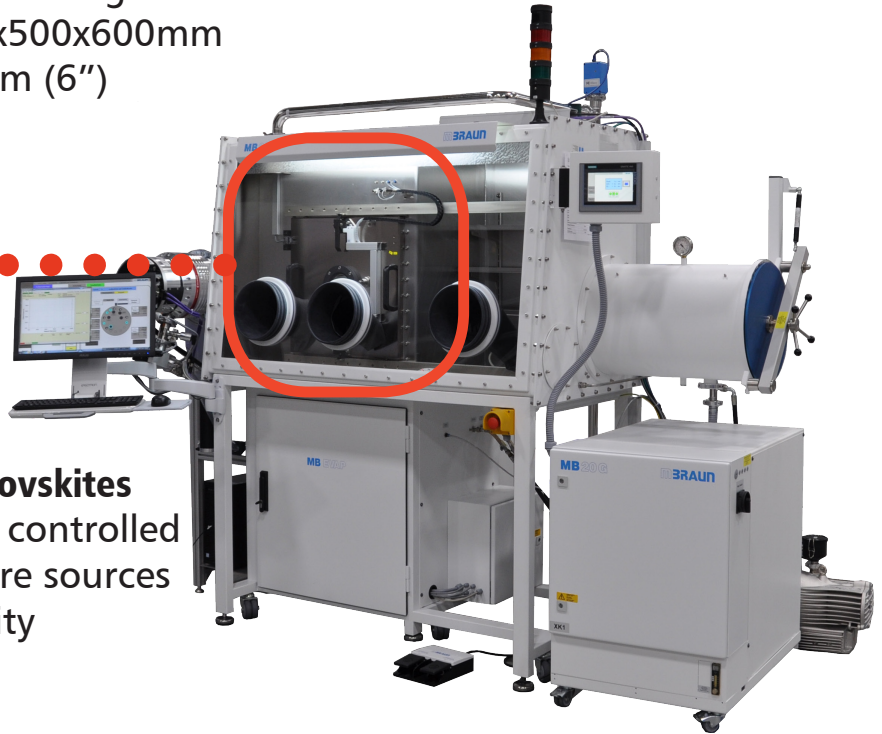


Deposition Tool for OLEDs and PEROVSKITES

- Integrated deposition tool in inert gloveboxes
- Vacuum chamber up to 500x500x600mm
- Substrate size up to Ø 150mm (6")
- Layer uniformity <3%

PROvap



- Special configuration for **Perovskites**
- Inner enclosure temperature controlled
- Special Ultra-Low Temperature sources
- High stability and repeatability

MINI PEROvap

- Design for **Perovskites**
- Compact design
- Economic solution
- Can be integrated in gloveboxes
- Designed for Organic and Perovskite compounds

